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Substitute for form 1449B/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	10/644 957
(Use as many sheets as necessary)				Filing Date	08/21/2003
				First Named Inventor	Gordon BEASE
				Art Unit	1763
				Examiner Name	MAUREEN G. ARANCIBIA
Sheet	1	of	1	Attorney Docket Number	071469-0305396

NON-PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	1	SWENGER ET AL., ""A Selective Etching Process for Chemically Inert High-k Metal Oxides", Mat. Res. Soc. Symp., Materials Research Society, p. 79-84, (2003).	

Examiner Signature	Maureen Chancie	Date Considered	02/18/2005
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***EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.**

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.

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FORM PTO-1449 (modified)
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Atty. Dkt. No.	M#	Client Ref.
	071469-0305396	PC8014A2
Applicant: Bease et al.		
Appln. No.: 10/644,957		
Filing Date: August 21, 2003		
Examiner: Unassigned Group Art Unit: 1763		

INFORMATION DISCLOSURE STATEMENT
 BY APPLICANT



Date: May 6, 2004

Page 1 of 1

U.S. PATENT DOCUMENTS

MAUREEN G. ARANCIBIA

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
MG	AR	6258608	07/2001	Jung			
MG	BR	4940509	07/1990	Tso et al.			
MG	CR	4690728	09/1987	Tsang et al.			
MG	DR	US20020043340	04/2002	Kojima et al.			
MG	ER	US20030104706	06/2003	Mitsuhashi et al.			
	FR						
	GR						
	HR						
	IR						
	JR						
	KR						
	LR						
	MR						
	NR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name	English Abstract		Translation Readily Available	
						Enclosed	No	Enclose	No
	OR								
	PR								
	QR								
	RR								
	SR								
	TR								
	UR								

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

MG	VR	Thomas et al., "A Practical PZT Dry Etching Process That Increases the Top Electrode Contact Reliability in Pyroelectric Detector Arrays by Using a MORI High Density Plasma System," 2001 IEEE/SEMI Advanced Semiconductor Manufacturing Conference, pp 81-83.			
MG	WR	International Search Report from PCT/US03/26496, dated April 14, 2004, which is related to the instant application.			
	XR				
	YR				
	ZR				
	AAR				

Examiner Maureen G. Arancibia

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